

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	"20050255622"	US-PGPUB; USPAT	OR	ON	2008/09/22 10:37
L2	1	(process electrode insulation contact hole indium zinc oxide etching rate).clm.	US-PGPUB; USPAT	AND	ON	2008/09/22 10:39
L3	952	LCD etch and indium zinc oxide process pattern gate signal line	US-PGPUB; USPAT	AND	ON	2008/09/22 10:40
L4	951	method LCD etch and indium zinc oxide process pattern gate signal line	US-PGPUB; USPAT	AND	ON	2008/09/22 10:40
L5	144999	"438"/\$3.ccls.	US-PGPUB; USPAT	AND	ON	2008/09/22 10:40
L6	328	4 and 5	US-PGPUB; USPAT	AND	ON	2008/09/22 10:40
L7	139	4 and 5	USPAT	AND	ON	2008/09/22 10:46
L8	952	LCD etch and indium zinc oxide process pattern gate signal line	US-PGPUB; USPAT	AND	ON	2008/09/22 11:08
L9	152361	"257"/\$3.ccls.	US-PGPUB; USPAT	AND	ON	2008/09/22 11:08
L10	350	8 9	US-PGPUB; USPAT	AND	ON	2008/09/22 11:08
L11	139	8 9	USPAT	AND	ON	2008/09/22 11:08
L12	9161	((257/347) or (257/40) or (257/411) or (438/34) or (438/148) or (438/158) or (438/155)).CCLS.	US-PGPUB; USPAT	OR	OFF	2008/09/22 11:12
L13	5236	((257/347) or (257/40) or (257/411) or (438/34) or (438/148) or (438/158) or (438/155)).CCLS.	USPAT	OR	OFF	2008/09/22 11:12

9/22/2008 11:28:13 AM

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